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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Examiner: not yet known

David L. Adler, et al.

Serial No.: 10/017,262

Art Unit: 2878

Filed: December 14, 2001

Title: *PHOTOELECTRON EMISSION MICROSCOPE FOR WAFER AND RETICLE
INSPECTION*

Commissioner of Patents
Washington, DC 20231

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ASSOCIATE POWER OF ATTORNEY

Sir:

The following persons are hereby appointed as Associate Attorneys to prosecute the above-referenced application and any continuing applications, to maintain the ensuing patent, and to transact all other business in the U.S. Patent and Trademark Office connected therewith:

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Dated: 6/18/02

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CERTIFICATE OF MAILING

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the Commissioner for Patents, Washington, D.C. 20231, on

Date: 6/20/02 By: [Signature]
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